

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#5 / DS  
11-27-01  
R. Stokun

In re New **Patent** Application of )  
 Jun Koyama et al )  
 Japanese Priority No.: 2000/023656 ) Attn: Applications  
 Japanese Priority Date: February 1, 2000 ) Branch  
 For: NONVOLATILE MEMORY, SEMICONDUCTOR )  
 DEVICE AND METHOD OF MANUFACTURING THE ) Date: February 1, 2001  
 SAME )

INFORMATION DISCLOSURE STATEMENT AND  
NOTIFICATION OF RELATED APPLICATION

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

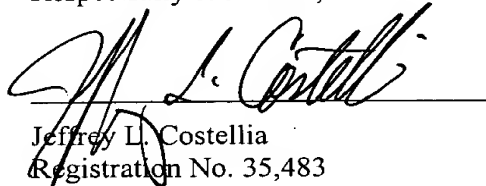
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. At least some of the references listed on the PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The attention of the examiner is directed to application Serial No. 09/156,913 which is related to Japanese Laid-Open No. JP 11-154714.

Respectfully submitted,



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JLC/sas